

Low E e- driven e+ source

as a summary of e+ meeting on 09/01/13.

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Low E e- driven e+ source

- The low E e- driven e+ source has been proposed by MK at ILC08. It was updated by considering DR acceptance.
- Critical investigation was made by W. Liu and W. Gai (ANL group).
- Two studies are compared.



Positron Yield study (MK)

- Positron generation is simulated by NRC-EGS4 with various electron energy (0.25 6.0 GeV) as a function of the target thickness (0.5 8.0 X₀).
- ► Beam spot : 2.5mm radius (rms)
- Capture optics: AMD (B₀=7.0T, B₅=0.5T, L=220mm, μ=60.8 1/m)
- ▶ Positron acceptance is qualified by an analytical method .
- ► DR acceptance is accounted. The real yield is 87% of the yield at AMD + capture RF.
- ▶ No enhancement was assumed by Lithium lens.



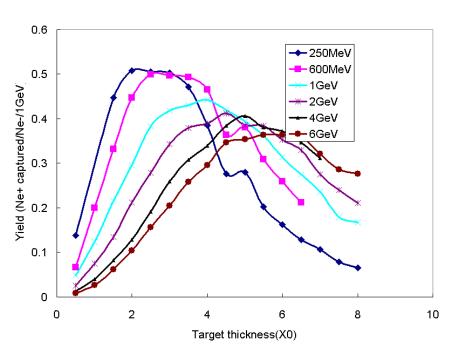
Schematic layout of beamline used for tracking (ANL)

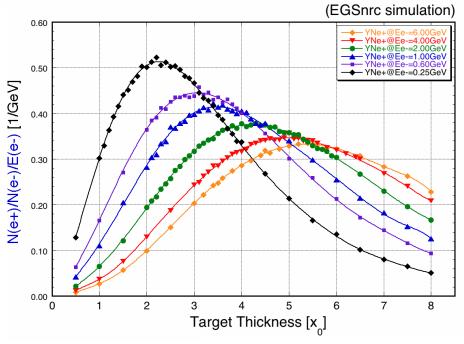
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Liquid lead target:
              X0 = \sim 0.5975cm
              C=162.9-3.022e-2*T+8.341e-6*T^2 [J/(kg*K)]
              K=9.2+0.011*T [W/(m*K)]
              ρ=11367-1.1944*T [kg/m<sup>3</sup>]
     Melting point: 600K, Boiling point: 2022K
     At melting point, 1 J/cm<sup>3</sup> can cause ~1.5K temperature change
AMD (6T) or
                  Field map of 1.3GHz RF standing wave cavities. ~1.15m long,
Lithium lens
                  surrounded by 0.5T solenoid, with ~12MV/m gradient
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EM shower is simulated by EGS4.



Positron Yield





by W. Liu and W. Gai

NRC EGS4 by T. Kamitani

Positron yield $\eta(N_{e+}/N_{e-}/GeV)$

▶ 0.6 GeV: 0.50

▶ 1.0 GeV : 0.45

▶ 2.0 GeV: 0.40

► 0.6 GeV: 0.44

▶ 1.0 GeV : 0.39

► 2.0 GeV: 0.37



Drive Energy (MK)

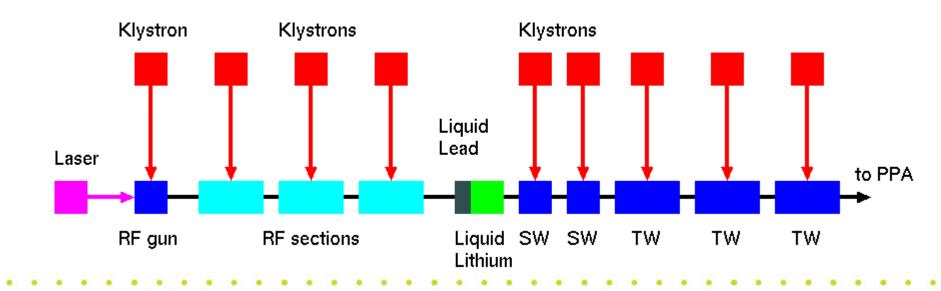
- The positron yield at the shower max for each energy is taken from the simulation.
- DR acceptance is smaller than AMD acceptance. The real yield is 87%, which corresponds to 1.5σ.
- ▶ No Enhancement by Lithium lens is assumed.
- ▶ The required drive beam intensity was obtained.

Ee- (GeV)	η	Ne- (nC)
0.7	0.27	11.85
1.4	0.48	6.67
2.2	0.71	4.51



ILC e+ source (MK)

- L-band RF gun (FLASH type) generates ILC format beam with 4.5nC bunch intensity.
- Three RF sections (2 klystron + 3 cryomodules, 24 cavities) accelerate it up to 2.2 GeV.
- Liquid lead target + Liquid Lithium lens.



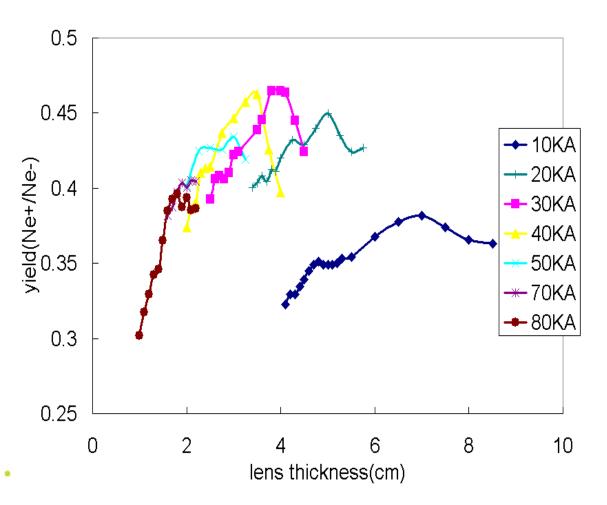


Target vitality (MK)

- Operation is limited by BN isolation window.
 - ► 10x10¹² GeV/mm² in 100ns duration
 - ▶ 180kW average power
- ► 2.2GeV, 4.5nC bunch with 369ns spacing, 2625 bunches, 5Hz
 - > 3.1x10⁹ GeV/mm² (spot size 20mm²)
 - 2.2x4.5x2625x5=130kW
- Both limits are cleared. The average power would be half for LowP.
- The spot size can be smaller; The acceptance may be improved.
- Those limits should be confirmed by experiments.



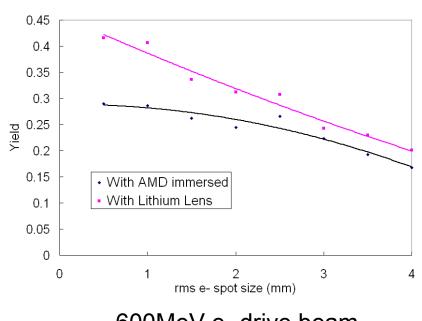
Lithium lens, 700MeV, 3X₀ liquid Pb (ANL)

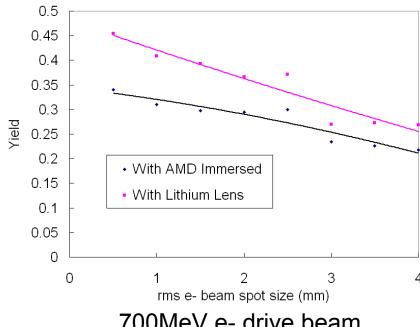


As showing in this figure, the maximum yield is about 0.46 when lithium lens is about 4cm thick and driven by 30KA current.

Comparing with yield of~0.33 achieved by using AMD and immersed liquid lead target, using lithium lens only enhanced the capture by ~40%.

Yield for different rms spot size of drive e- beam (ANL)





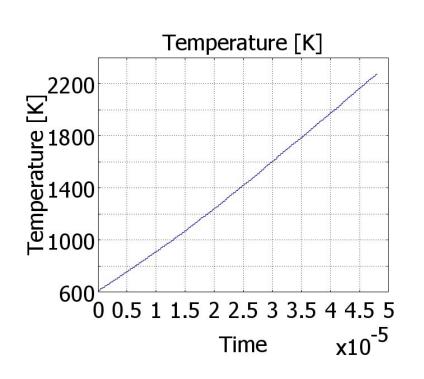
600MeV e- drive beam

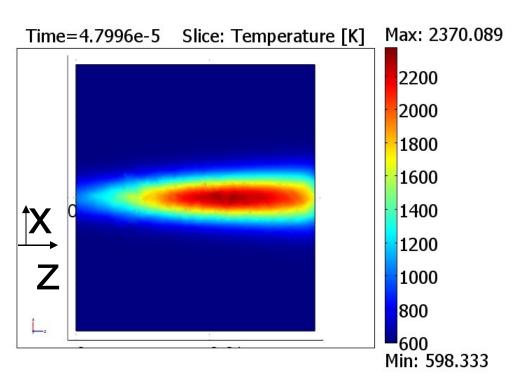
700MeV e- drive beam

AMD is 6T to 0.5 T in 14 cm for all data points. Lithium lens parameters are optimized for each case. We optimized both the thickness and the driving current density. The current is assumed to be uniform in the lens.

Increasing of the drive e- beam spot size will lower the yield enhancement from lithium lens

Heat transfer simulation up to 130 bunches, 700MeV·drive·beam, 1mm·spot size, AMD·immersed target (ANL)





The difference between 700MeV and 600MeV drive e- is very small at this point.



III Summary of the studies.

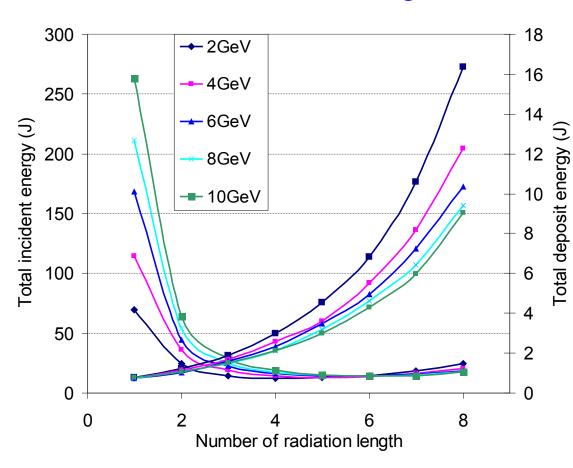
Nama	o (Co\/)	Spot	Pb flow	Yield	Ne-	NB limit
Name	e- (GeV)		(m/s)	e+/e-	(nC)	IND IIIIIL
MK1	0.7	2.5	-	0.27	11.85	-
MK2	1.4	2.5	-	0.48	6.67	-
MK3	2.2	2.5	-	0.71	4.51	-
ANL1	0.7	1.0	10	0.45	7.11	182
ANL2	0.7	3.0	10	0.27	11.85	1200
ANL3	0.7	3.0	30	0.27	11.85	Saturated at 1973K
ANL4	0.7	4.0	30	0.27	11.85	Saturated at 1600K

- MK proposed 2.2 GeV drive beam.
- Boiling of Liquid Pb (2200K) is a serious problem according to ANL's study.
- ► High speed flow (20-30m/s) and larger spot size (2-3mm) help to avoid the boiling.



Total incident energy and deposit energy (ANL).

Assuming 3nC e+ are captured



This figure from our previous conventional e+ source study shows that lower drive beam

☐ energy will result in a higher
☐ energy deposition in target.

Energy deposition per captured e+ does not have any strong dependence on the energy. It increases simply by X₀. (Comment by MK)



Optimization (MK)

- The positron yield as a function of X₀ has an optimum point, but the dependence is not strong.
- ➤ On the other hand, the energy deposition per captured positron is simply increased as a function of X₀.
- ▶ By considering both facts, another optimum is lower side of the extremum of the yield.

For 2.0 GeV drive beam

X0	Yield (Ne+/Ne-/GeV)	Energy Deposit per e+ (J/3nC)		
2	0.2	1.54		
3	0.32	1.88		
4	0.37	3		
5	0.35	4.52		



iib Optimization(2)...

- ► Let me assumed 3 X₀ operation, rather than 4X₀ for 2.2GeV drive beam.
- ► The positron yield (N_{e+}/N_{e-}) for 2.2GeV drive beam is 0.32x2.2=0.70.
- Taking account the DR acceptance and enhancement by lithium lens (30%), the yield becomes 0.70x0.87x1.3=0.80.
- The drive beam intensity giving 3.2nC e+ bunch is 3.2/0.8=4.0nC.

X0	Yield (Ne+/Ne-/GeV)	Energy Deposit per e+ (J/3nC)
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3	0.32	1.88
4	0.37	3
5	0.35	4.52



III Pb boiling extrapolation.

- ≥ 2.2GeV, 4.0nC drive beam cause 1.65 J energy deposition per bunch.
- ► ANL's Pb boiling study was made with 2.30 J energy deposition per bunch.
- If the temperature rise is scaled as the energy deposition, the expected results are

		Spot	Pb flow	Yield	Ne-	
Name	e- (GeV)	(mm)	(m/s)	e+/e-	(nC)	NB limit
ANL1	2.2	1.0	10	0.80	4.00	250
ANL2	2.2	3.0	10	0.80	4.00	1670
ANL3	2.2	3.0	30	0.80	4.00	Saturated at 1590K
ANL4	2.2	4.0	30	0.80	4.00	Saturated at 1300K



Pb.boiling.extrapolation (2)

		Spot	Pb flow	Yield	Ne-	
Name	e- (GeV)	(mm)	(m/s)	e+/e-	(nC)	NB limit
MKV1	2.2	1.0	10	0.80	4.00	250
MKV2	2.2	3.0	10	0.80	4.00	1670
MKV3	2.2	3.0	30	0.80	4.00	Saturated at 1590K
MKV3	2.2	4.0	30	0.80	4.00	Saturated at 1300K

- MKV1: no way?
- MKV2: Acceptable for LowP set.
- MKV3, MKV4: Acceptable for Nominal set.



Summary

- ➤ Two independent studies on the e- driven positron source were compared.
- The positron yield calculations were consistent to each other.
- Yield enhancement by Lithium lens comparing to AMD was shown by ANL's study.
- MK's study shows 2.2 GeV drive beam is a solution, but no enhancement by LL is assumed.
- ➤ ANL's study shows that Pb boiling is a serious issue. Larger spot size and higher flow speed avoid the boiling.



Summary (cont.)

- ► Accounting both yield and energy deposition, low X₀ point is another optimum.
- ▶ By assuming 2.2GeV drive beam, 30 m/s flow speed is required to avoid the boiling.
- ▶ 10 m/s speed is acceptable for LowP set.